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In re Application of	:	
Selvamanickam	:	
Serial Number: 10/609,250	:	
Filed: June 26, 2003	:	PETITION UNDER
For: APPARATUS FOR AND METHOD OF	:	M.P.E.P. 708.02 IX
CONTINUOUS HTS TAPE BUFFER LAYER	:	
DEPOSITION USING LARGE SCALE ION BEAM	:	
ASSISTED DEPOSITION	:	

This is in response to the petition filed June 26, 2003, requesting that the above-identified application be granted Special Status under Section 708.02 IX of the MPEP and 37 CFR 1.102 (b) (**no fee required**).

The request for Special Status considered under Section 708.02 IX of the MPEP is granted because criteria under 37 CFR 1.102(b) has been met.

Accordingly the petition is **GRANTED**.

Marian C. Knode

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